

Application No.:	10/736,999	§	Examiner:	5760-14800
Filed:	December 16, 2003	§	Group/Art Unit:	Rayyan, Susan F.
Inventor(s):		§	Atty. Dkt. No:	2167
	Gavriela D. Lavie and	§		
	Shiri Kerman-Hendell	§		
Title:	CAUSE TO EFFECT	§		
	METHODOLOGY FOR	§		
	MONITORING	§		
	DATABASE	§		
	PERFORMANCE	§		

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

This paper is submitted in response to the Office Action of June 4, 2007, to further highlight why the application is in condition for allowance.

1 / 12